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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	§	
Qing Ma et al.	§	Art Unit: 2822
	§	
Serial No.: 10/643,427	§	
	§	Examiner: Kiesha L. Rose
Filed: August 19, 2003	§	
	§	
For: Packaging Microelectromechanical Structures	§	Atty Docket: ITL.0725D1US P14251D
	§	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 101304

Sir:

In response to the office action mailed October 19, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: November 30, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
Cynthia L. Hayden
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